

# PROCEEDINGS OF SPIE

## ***MEMS Adaptive Optics III***

**Scot S. Olivier**  
**Thomas G. Bifano**  
**Joel A. Kubby**  
*Editors*

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# Contents

- vii *Conference Committee*
- ix *The high versatility of silicon based micro-optical modulators (Plenary Paper) [7208-101]*  
*H. Schenk, Fraunhofer Institute for Photonic Microsystems (Germany)*

---

## SESSION 1 MEMS AO FOR BIO-IMAGING

---

- 7209 03 **Two-photon fluorescence microscopy with differential aberration imaging (Invited Paper)** [7209-02]  
K. K. Chu, A. Leray, T. G. Bifano, J. Mertz, Boston Univ. (United States)
- 7209 04 **Optimum schemes for wavefront sensorless adaptive optics in microscopy (Invited Paper)** [7209-03]  
D. Débarre, B. Wang, T. Wilson, M. J. Booth, Univ. of Oxford (United Kingdom)
- 7209 05 **Performance of a MEMS-based AO-OCT system using Fourier reconstruction** [7209-04]  
J. W. Evans, Lawrence Livermore National Lab. (United States) and Univ. of California, Davis (United States); R. J. Zawadzki, Univ. of California, Davis (United States); S. Jones, S. Olivier, Lawrence Livermore National Lab. (United States); J. S. Werner, Univ. of California, Davis (United States)
- 7209 06 **Implementation of a Shack-Hartmann wavefront sensor for the measurement of embryo-induced aberrations using fluorescent microscopy** [7209-05]  
O. Azucena, J. Kubby, J. Crest, J. Cao, W. Sullivan, Univ. of California, Santa Cruz (United States); P. Kner, Univ. of California, San Francisco (United States); D. Gavel, D. Dillon, Univ. of California, Santa Cruz (United States); S. Olivier, Lawrence Livermore National Lab. (United States)

---

## SESSION 2 MEMS AO FOR LASERS AND COMMUNICATIONS

---

- 7209 07 **Interferometric adaptive optics for high-power laser pointing, wavefront control, and phasing (Invited Paper)** [7209-06]  
K. L. Baker, Lawrence Livermore National Lab. (United States); E. A. Stappaerts, Lawrence Livermore National Lab. (United States) and Stappaerts Consulting, LLC (United States); D. C. Homoelle, M. A. Henesian, E. S. Bliss, C. W. Siders, C. P. J. Barty, Lawrence Livermore National Lab. (United States)
- 7209 08 **Quantum control spectroscopy (QCS) with a micro-electro-mechanical-system (MEMS) (Invited Paper)** [7209-07]  
T. Buckup, J. Möhring, M. Motzkus, Philipps-Univ. Marburg (Germany)
- 7209 09 **Using MEMS mirrors to pattern electrical forces** [7209-27]  
S. L. Neale, H.-Y. Hsu, J. K. Valley, A. Jamshidi, M. C. Wu, Univ. of California, Berkeley (United States)

7209 0A **MEMS for femtosecond pulse shaping applications** [7209-08]  
A. Rondi, J. Extermann, S. M. Weber, L. Bonacina, Univ. of Geneva (Switzerland);  
J. D. Roslund, M. H. Roth, H. A. Rabitz, Princeton Univ. (United States); J.-P. Wolf, Univ. of  
Geneva (Switzerland)

7209 0B **Novel construction of a deformable mirror for laser beam shaping** [7209-09]  
C. Bruchmann, Friedrich Schiller Univ. of Jena (Germany) and Fraunhofer Institute for  
Applied Optics and Precision Engineering (Germany); R. Eberhardt, E. Beckert, T. Peschel,  
S. Gramens, Fraunhofer Institute for Applied Optics and Precision Engineering (Germany);  
S. E. Gebhardt, Fraunhofer Institute for Ceramic Technologies and Systems (Germany);  
A. Tünnermann, Friedrich Schiller Univ. of Jena (Germany) and Fraunhofer Institute for  
Applied Optics and Precision Engineering (Germany)

7209 0C **Secure optical communication system utilizing deformable MEMS mirrors (Invited Paper)**  
[7209-10]  
L. Ziph-Schatzberg, Boston Univ. (United States); T. Bifano, Boston Univ. (United States) and  
Boston Micromachines Corp. (United States); S. Cornelissen, J. Stewart, Boston  
Micromachines Corp. (United States); Z. Bleier, PLX Inc. (United States)

---

### SESSION 3 MEMS AO FOR ASTRONOMY

---

7209 0E **MEMS devices in future astronomical telescope adaptive optics instruments (Invited Paper)**  
[7209-12]  
D. Gavel, UCO/Lick Observatory, Univ. of California, Santa Cruz (United States)

7209 0F **The Naval Research Laboratory MEM adaptive optics program (Invited Paper)** [7209-13]  
S. R. Restaino, T. Martinez, J. R. Andrews, C. C. Wilcox, F. Santiago, Naval Research Lab.  
(United States); D. M. Payne, Narrascope, Inc. (United States)

7209 0G **Demonstration of a symmetric dark hole with a stroke-minimizing correction algorithm**  
[7209-14]  
J. D. Kay, Princeton Univ. (United States); L. A. Pueyo, Jet Propulsion Lab. (United States);  
N. J. Kasdin, Princeton Univ. (United States)

7209 0I **Preliminary characterization of Boston Micromachines' 4096-actuator deformable mirror**  
[7209-16]  
A. Norton, J. W. Evans, D. Gavel, D. Dillon, UCO/Lick Observatory, Univ. of California, Santa  
Cruz (United States); D. Palmer, B. Macintosh, Lawrence Livermore National Lab. (United  
States); K. Morzinski, UCO/Lick Observatory, Univ. of California, Santa Cruz (United States);  
S. Cornelissen, Boston Micromachines Corp. (United States)

---

### SESSION 4 AO IN CHINA

---

7209 0J **Adaptive optics at the IOE, CAS (Invited Paper)** [7209-18]  
W. Jiang, C. Rao, Y. Zhang, N. Ling, C. Guan, Institute of Optics and Electronics (China)

---

**SESSION 5 MEMS AO DEVICES**

---

- 7209 0K **Design and analysis of repulsive electrostatic driven MEMS actuators (Invited Paper)** [7209-19]  
J. Yao, F. Hu, D. Cai, W. Jiang, Institute of Optics and Electronics (China)
- 7209 0L **Scaling of the Iris AO segmented MEMS DM to larger arrays (Invited Paper)** [7209-20]  
M. A. Helmbrecht, M. He, C. J. Kempf, Iris AO, Inc. (United States)
- 7209 0M **Advanced optical coatings of a segmented MEMS DM** [7209-21]  
M. A. Helmbrecht, M. He, Iris AO, Inc. (United States)
- 7209 0N **Novel unimorph deformable mirror for solid state laser resonators** [7209-22]  
S. Verpoort, P. Welp, U. Wittrock, Muenster Univ. of Applied Sciences (Germany)
- 7209 0O **Initial performance results for high-aspect ratio gold MEMS deformable mirrors** [7209-23]  
B. Fernández, J. Kubby, Univ. of California, Santa Cruz (United States)

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**POSTER SESSION**

---

- 7209 0P **Liquid crystal adaptive optics system for unpolarized light** [7209-24]  
D. Cai, Institute of Optics and Electronics (China) and Taiyuan Univ. of Technology (China);  
J. Yao, W. Jiang, Institute of Optics and Electronics (China)
- 7209 0Q **Optical efficiency of MEMS deformable mirror for adaptive optics** [7209-25]  
D. Cai, Institute of Optics and Electronics (China) and Taiyuan Univ. of Technology (China);  
J. Yao, W. Jiang, Institute of Optics and Electronics (China)

*Author Index*



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